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In re the Application of: **Hitoshi YAMADA et al.**

Group Art Unit: 1762

Serial No.: 10/642,271

Examiner: Mariannel Padgett

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Confirmation No.: **2420**

For: **METHOD OF FORMING METAL OXIDE FILM AND METHOD  
FOR FORMING SECONDARY ELECTRON EMISSION FILM IN  
GAS DISCHARGE TUBE**

Attorney Docket Number: **030933**

Customer Number: **38834**

**INFORMATION DISCLOSURE STATEMENT**  
**PURSUANT TO 37 C.F.R. §1.97(b)**

Commissioner for Patents  
P. O. Box 1450  
Alexandria, VA 22313-1450

Date: May 3, 2005

Sir:

In compliance with 37 C.F.R. §1.56, Applicants direct the attention of the Patent and Trademark Office to the documents listed on the attached PTO/SB/08. This paper is being filed within the time periods set forth in 37 C.F.R. §1.97(b). A copy of each non-U.S. document is enclosed herewith.

If there are any fees due in connection with the filing of this paper, please charge Deposit Account No. 50-2866.

Respectfully submitted,

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Enclosure: PTO/SB/08 and 1 Document

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